

Fermilab LDRD-2016-004

Develop a CCD-based detector with an energy threshold close to the silicon band gap (1.1 eV) and a readout noise of 0.1 electrons using a new generation skipper CCD developed by the LBNL MicroSystems Lab

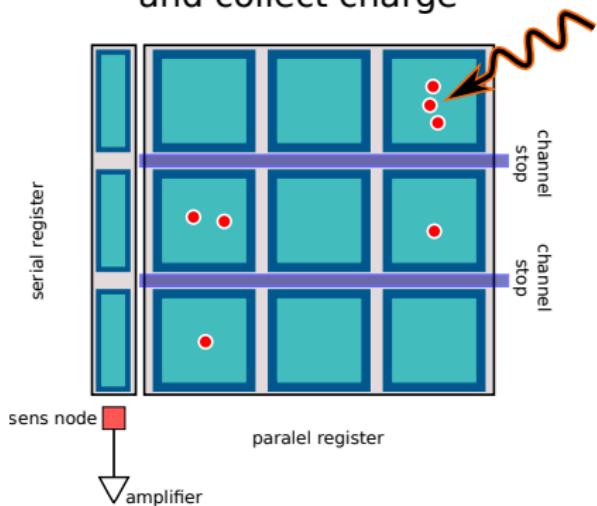
Plan

- Build the first working detector using Skipper-CCDs
- Optimize the operation parameters and running conditions
- Produce a low radiation package for the Skipper-CCDs
- Install the detector in a low radiation environment (MINOS)
- **Dvlp and validate a new technology for DM and ν experiments**

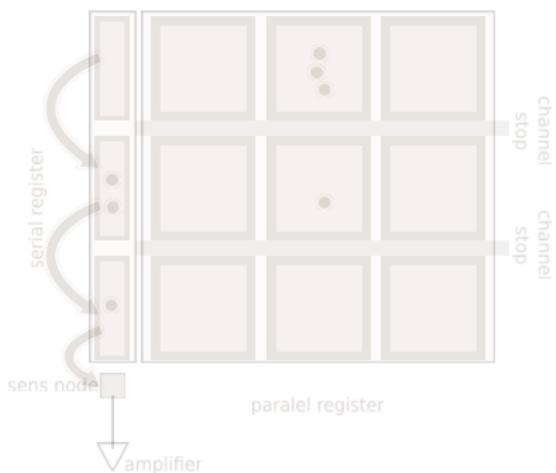
CCD: readout

3x3 pixels CCD

Expose the CCD to particles
and collect charge

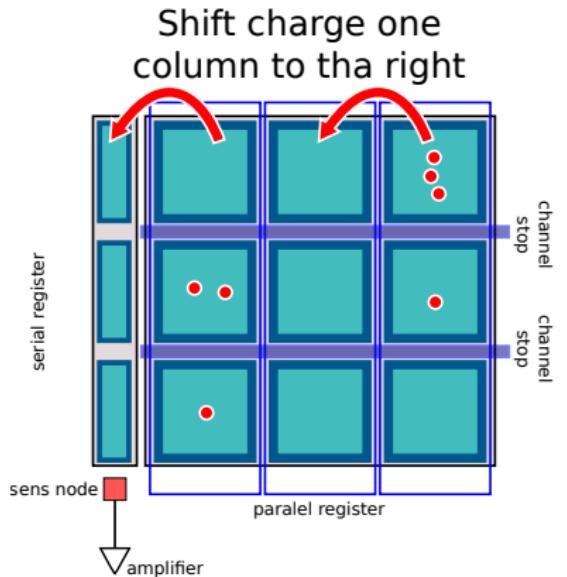


Shift charge in serial register
one pixel down (3 times)

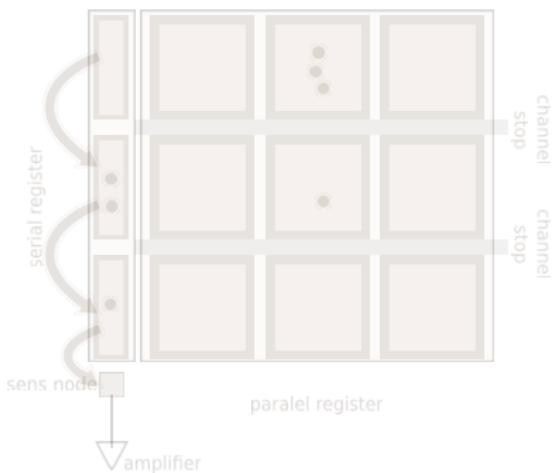


CCD: readout

3x3 pixels CCD



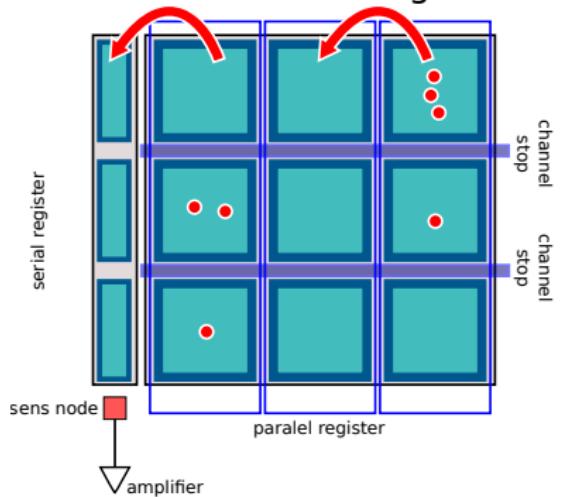
Shift charge in serial register
one pixel down (3 times)



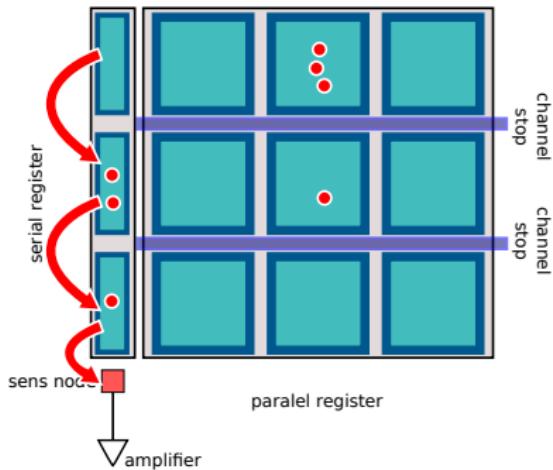
CCD: readout

3x3 pixels CCD

Shift charge one column to the right

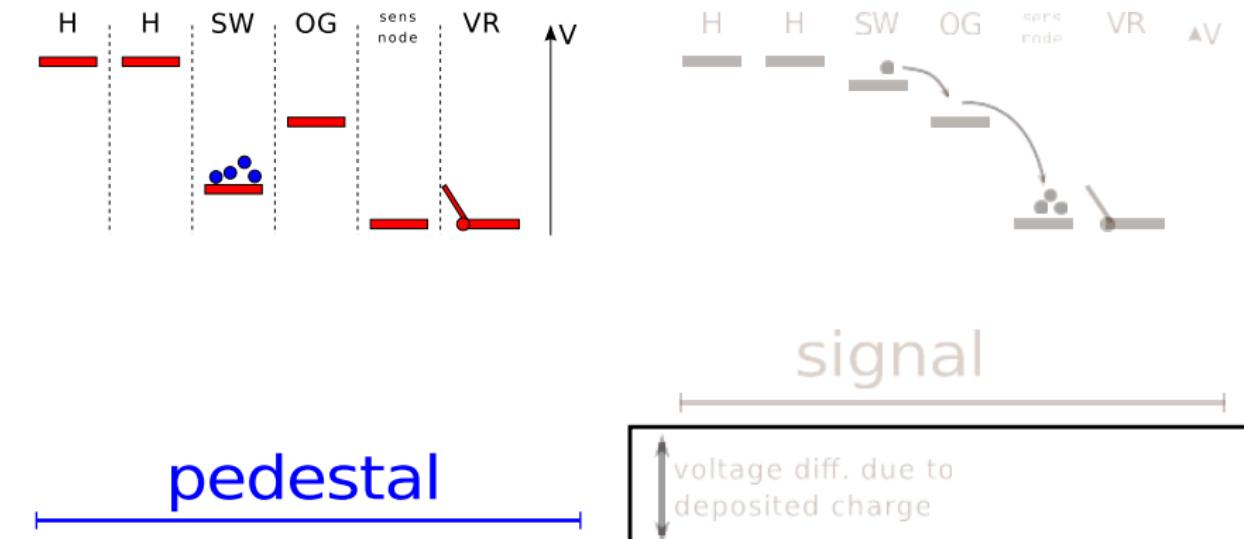


Shift charge in serial register one pixel down (3 times)

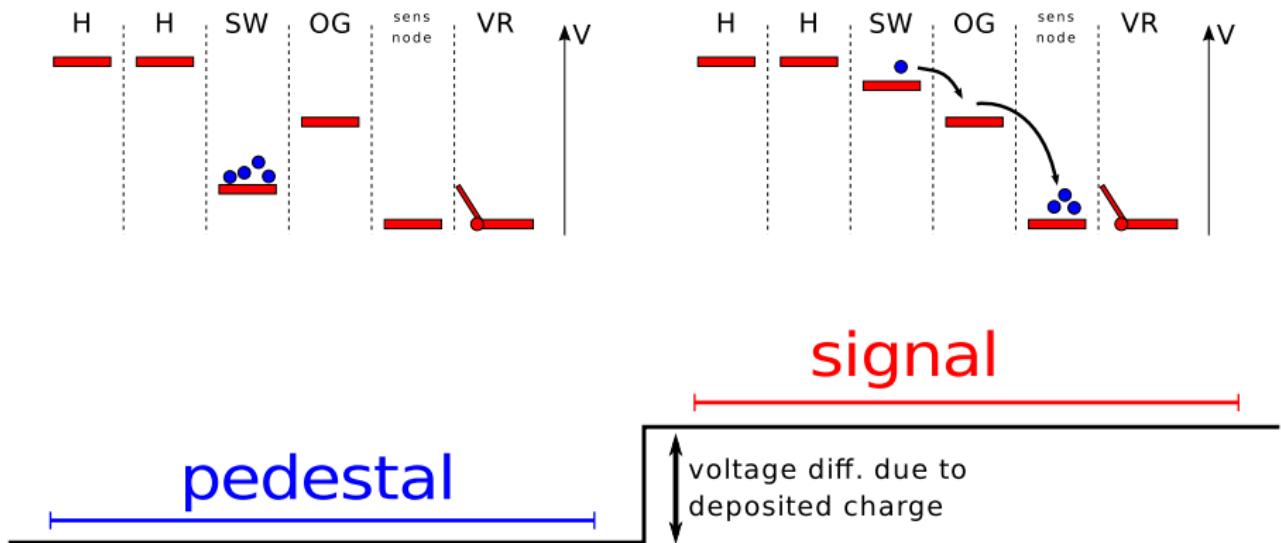


capacitance of the system is set by the SN: $C=0.05\text{pF} \rightarrow 3\mu\text{V/e}$

CCD: readout

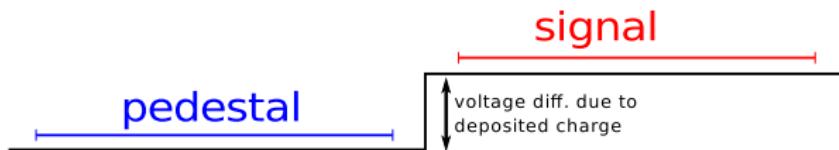


CCD: readout

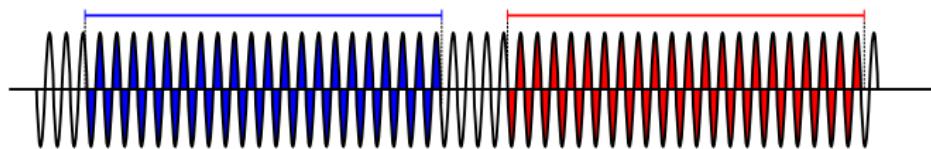


CCD: readout

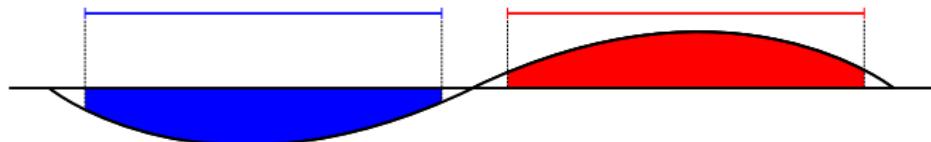
pixel charge measurement



high frequency noise

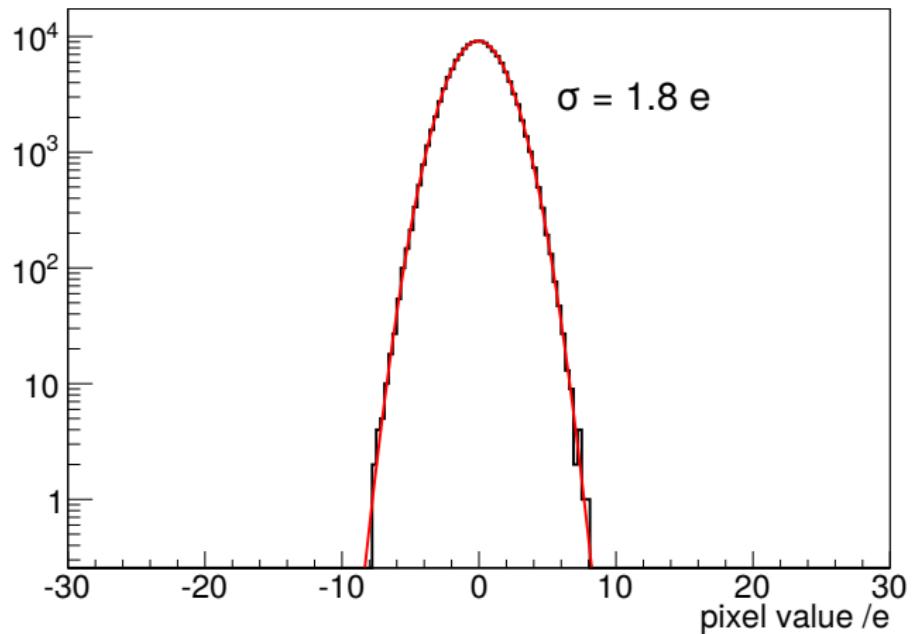


low frequency noise



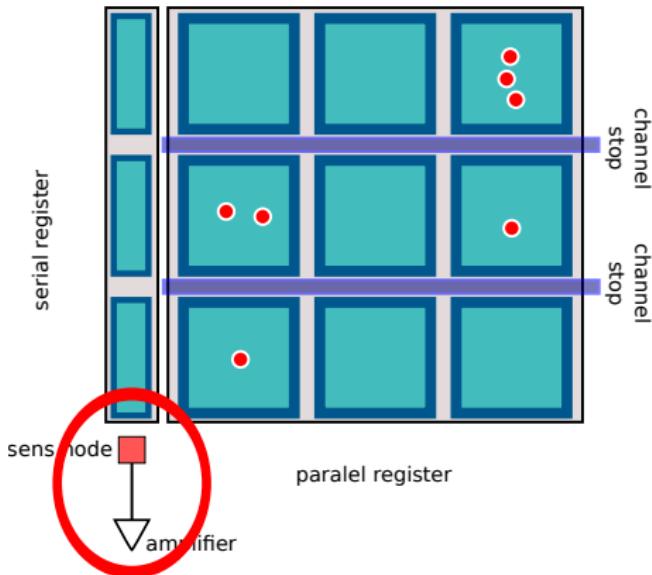
excellent for removing high frequency noise but sensitive to low frequencies

Readout noise: empty pixels distribution



2 e^- readout noise roughly corresponds to 50 eV energy threshold

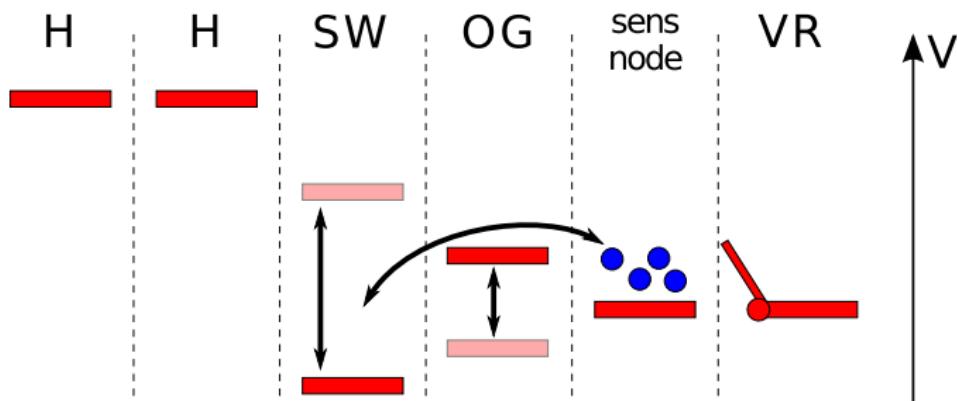
Lowering the noise: Skipper CCD



Only the readout stage is modified

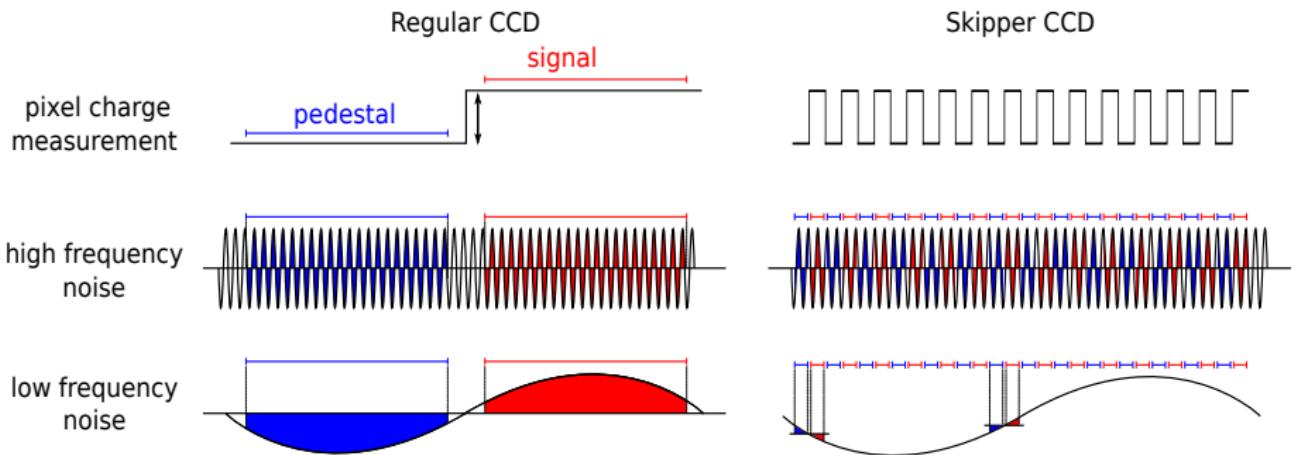
Lowering the noise: Skipper CCD

- **Main difference:** the Skipper CCD allows multiple sampling of the same pixel without corrupting the charge packet.
- The final pixel value is the average of the samples
$$\text{Pixel value} = \frac{1}{N} \sum_i^N (\text{pixel sample})_i$$
- Idea proposed in 1990 by Janesick et al. (doi:10.1117/12.19452)



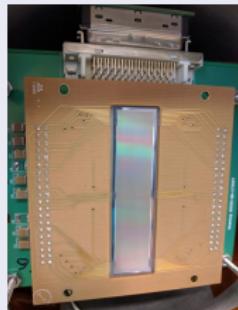
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SENSEI: First working instrument using SkipperCCD tech

Sensors



- Skipper-CCD prototype designed by LBL MSL
- 200 & 250 μm thick, 15 μm pixel size
- Two form factors $4\text{k}\times 1\text{k}$ & $1.2\text{k}\times 0.7\text{k}$ pixels
- Parasitic run, optic coating and Si resistivity $\sim 10\text{k}\Omega$
- 4 amplifiers per CCD, three different RO stage designs

Instrument



- System integration done at Fermilab
- Custom cold electronics
- Modified Monsoon system for read out
- Firmware and image processing software
- Optimization of operation parameters

Image taken with SENSEI: 4000 samples per pixel (processed)

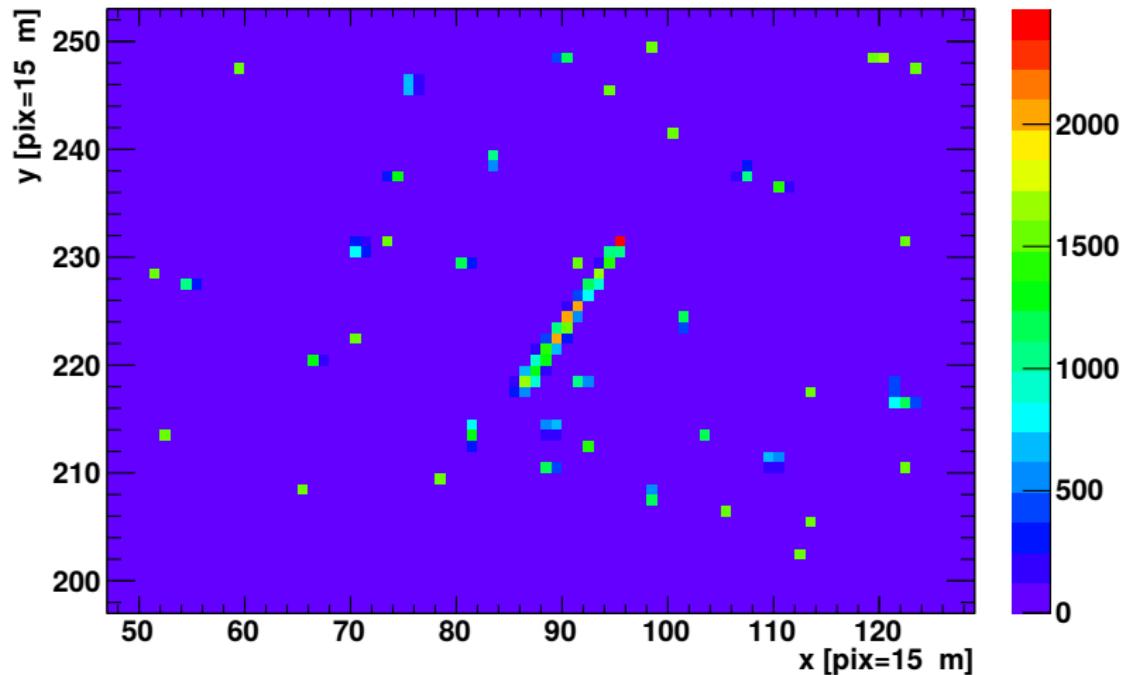


Image taken with SENSEI: 4000 samples per pixel (processed)

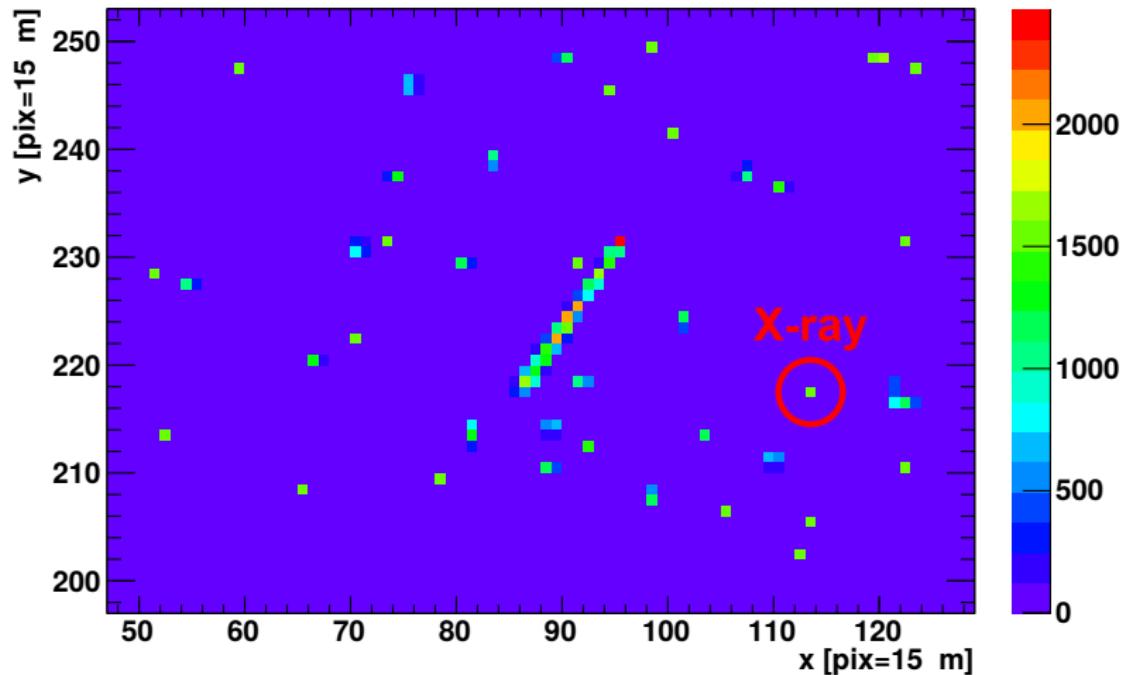


Image taken with SENSEI: 4000 samples per pixel (processed)

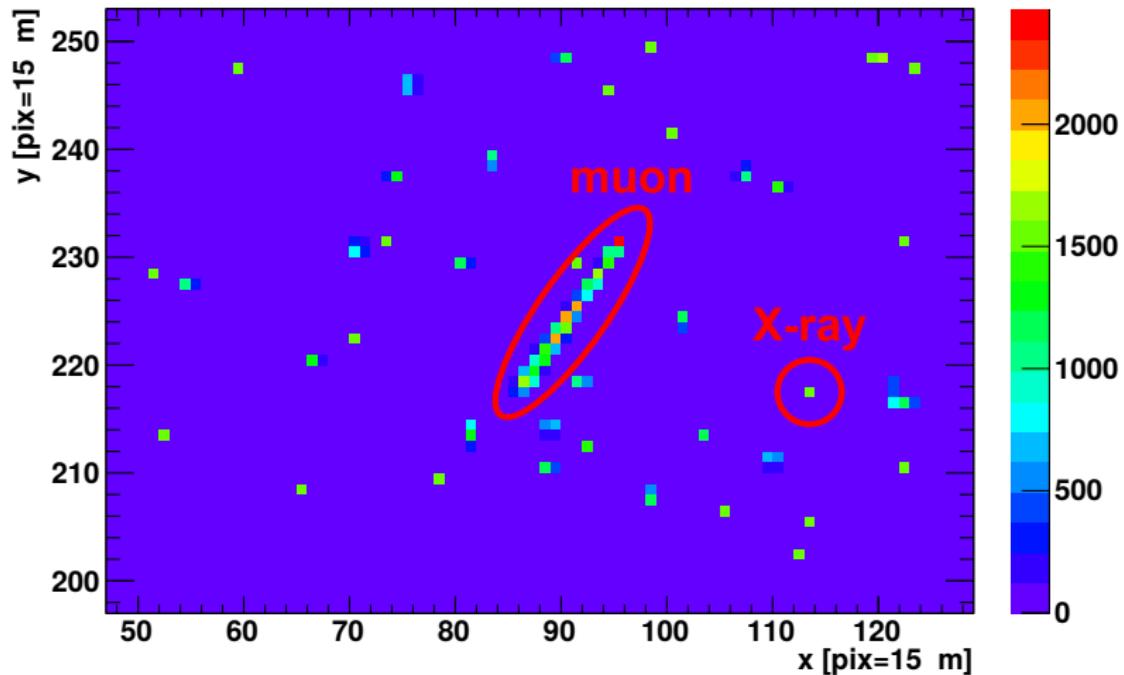
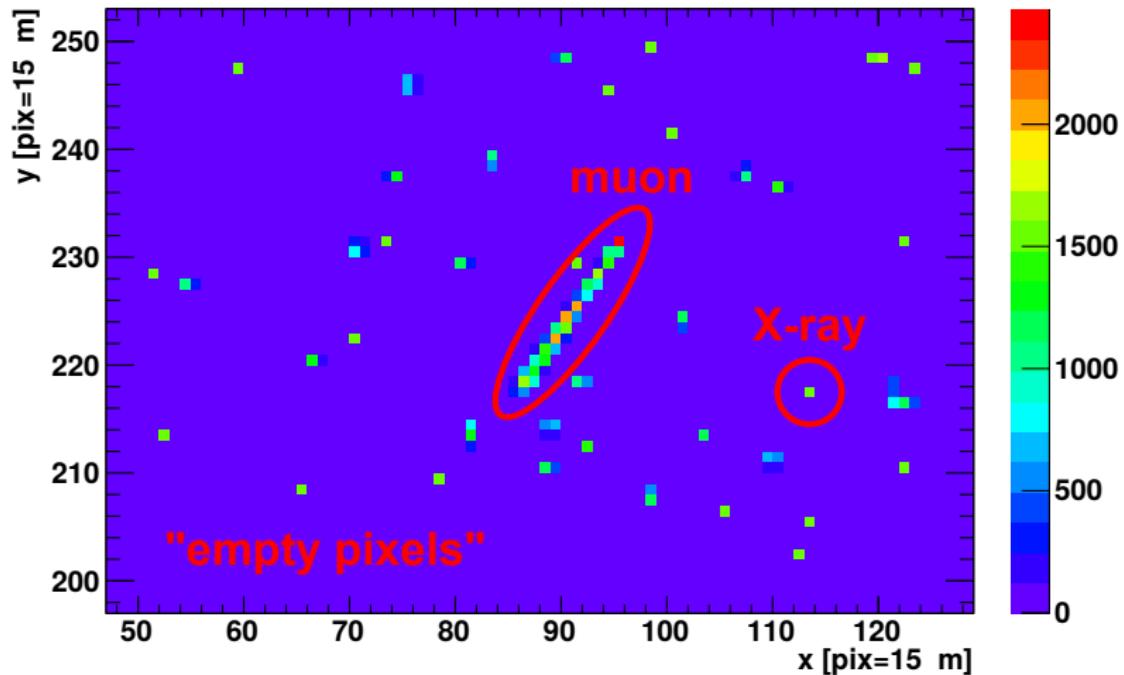
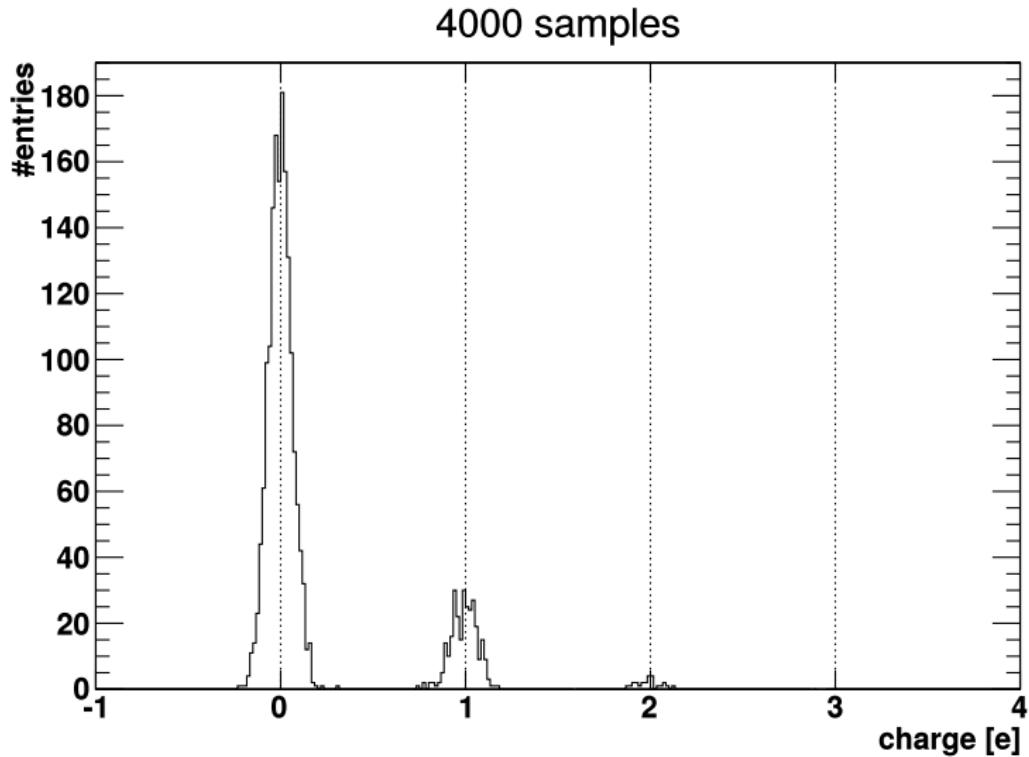


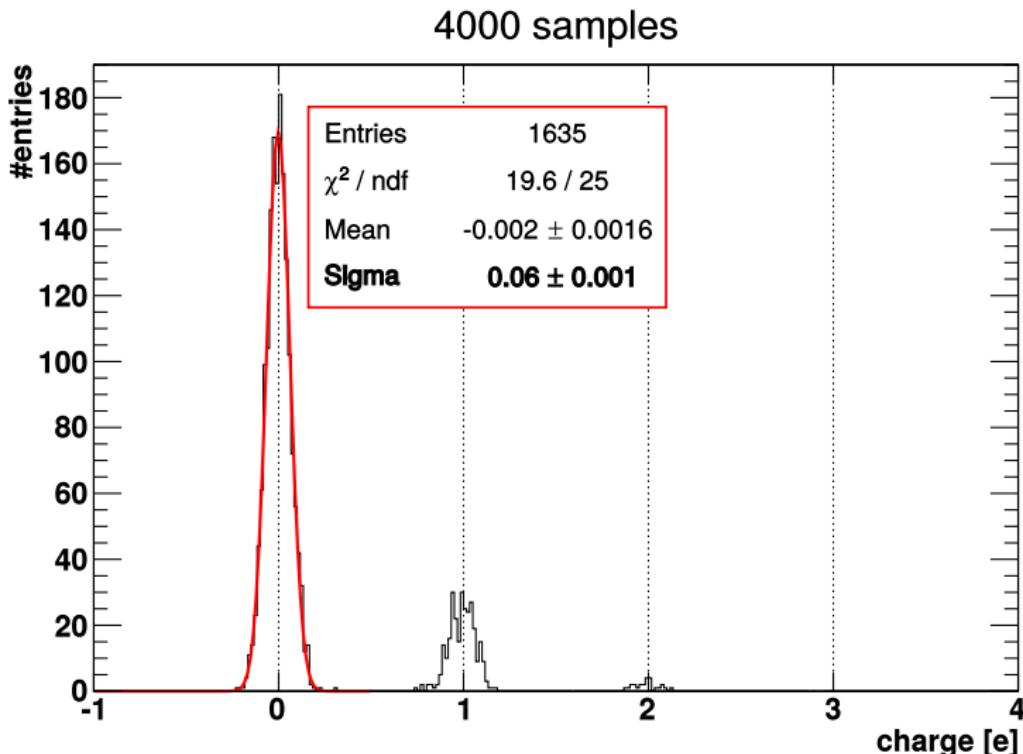
Image taken with SENSEI: 4000 samples per pixel (processed)



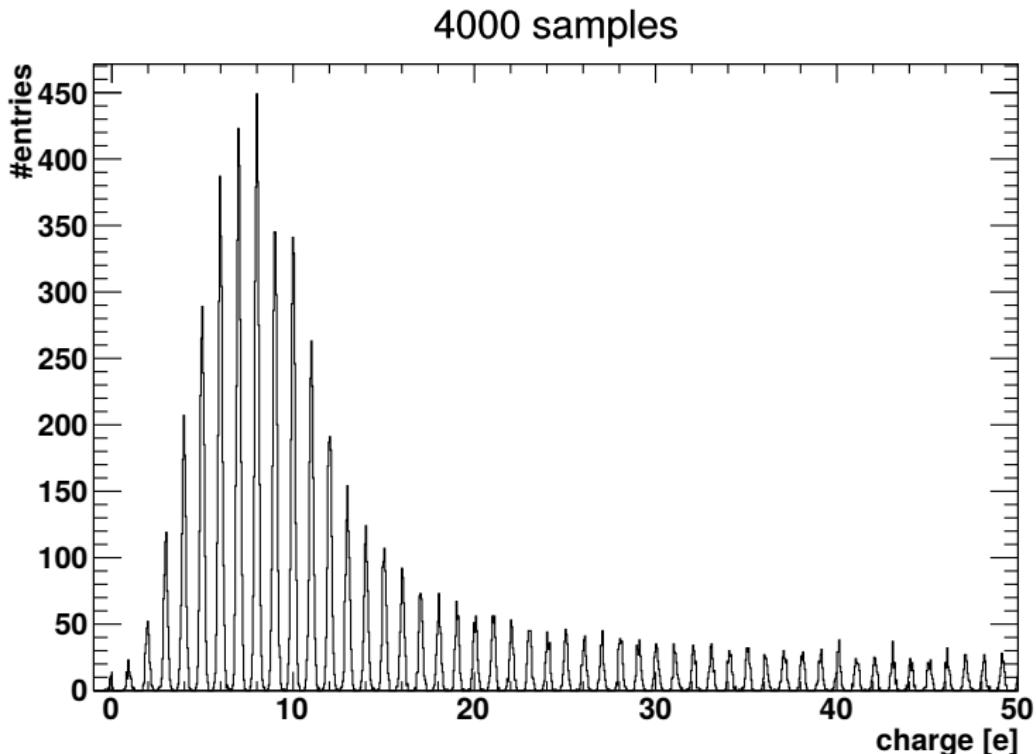
Charge in pixel distribution. Counting electrons: 0, 1, 2..



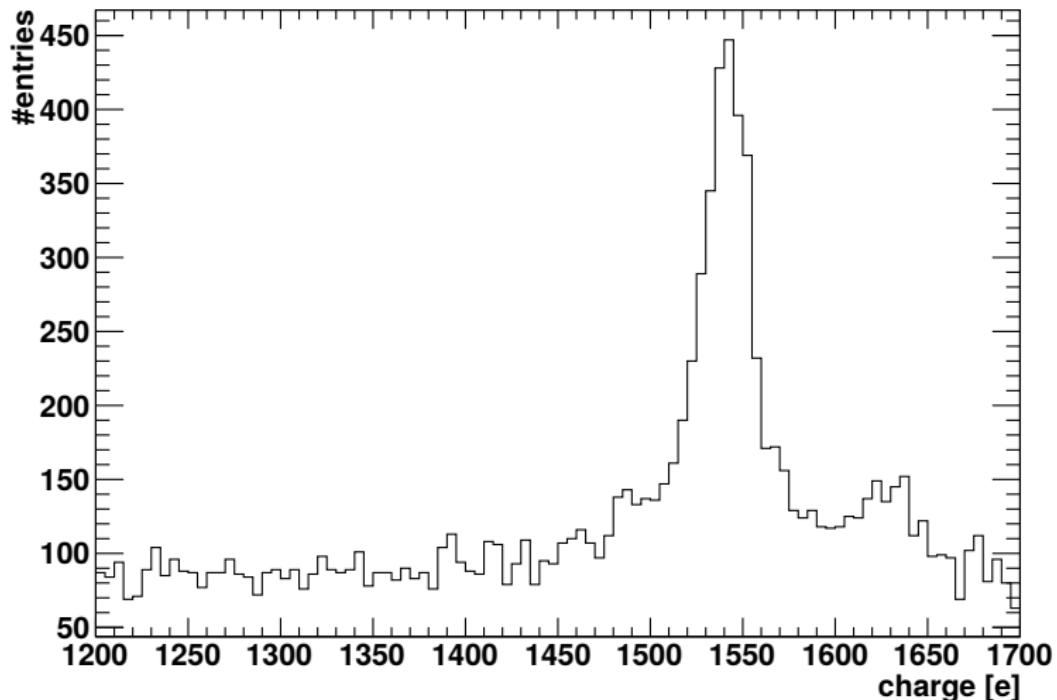
Charge in pixel distribution. Counting electrons: 0, 1, 2..



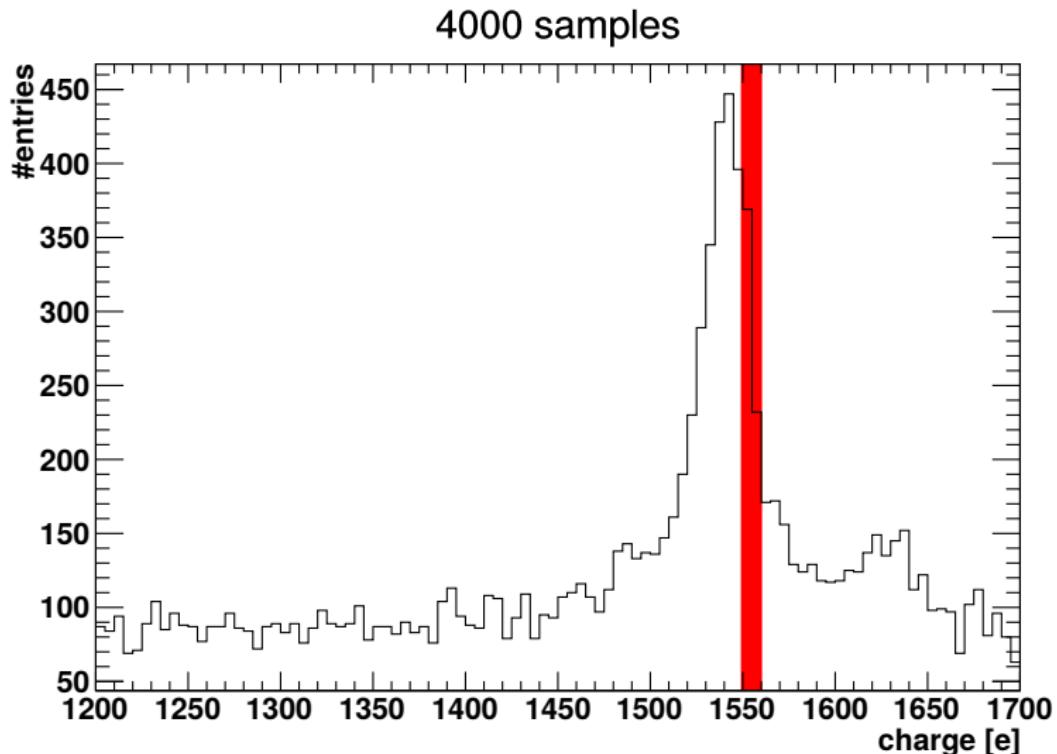
Counting electrons: ..48, 49, 50..



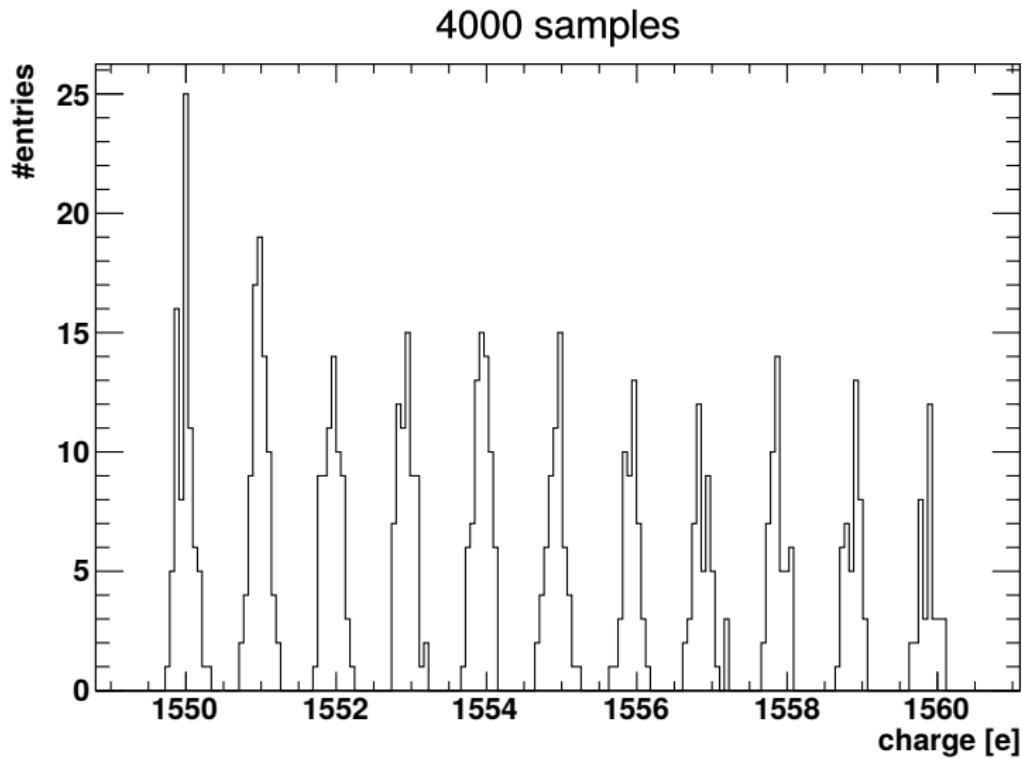
4000 samples



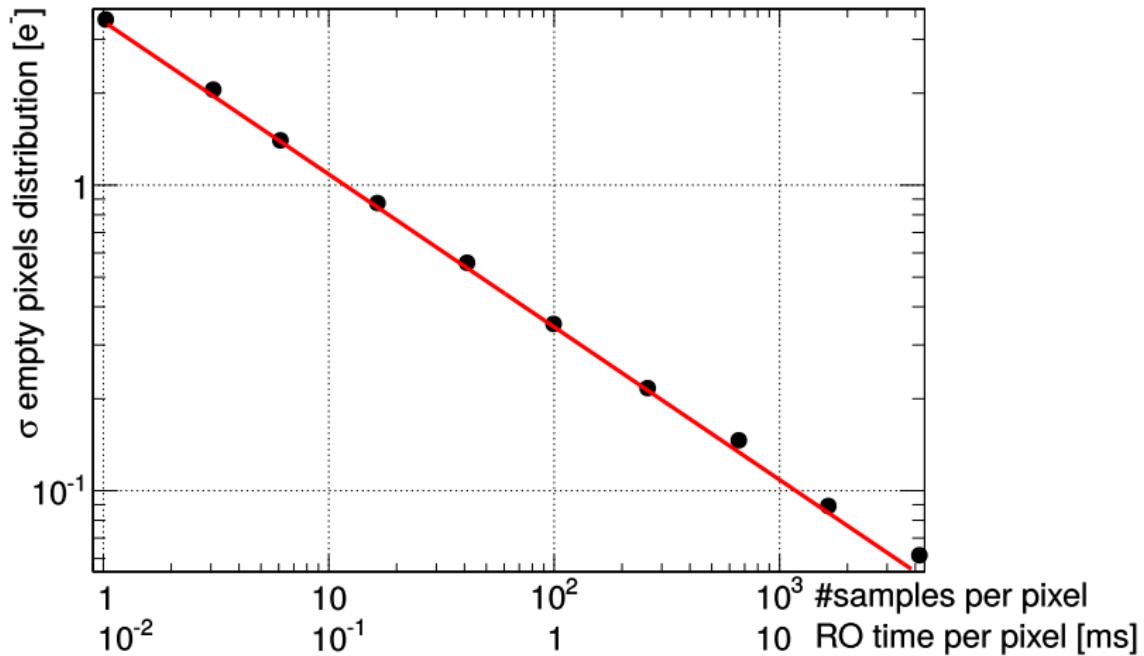
^{55}Fe X-ray source



keep counting: ..1550, 1551, 1552..

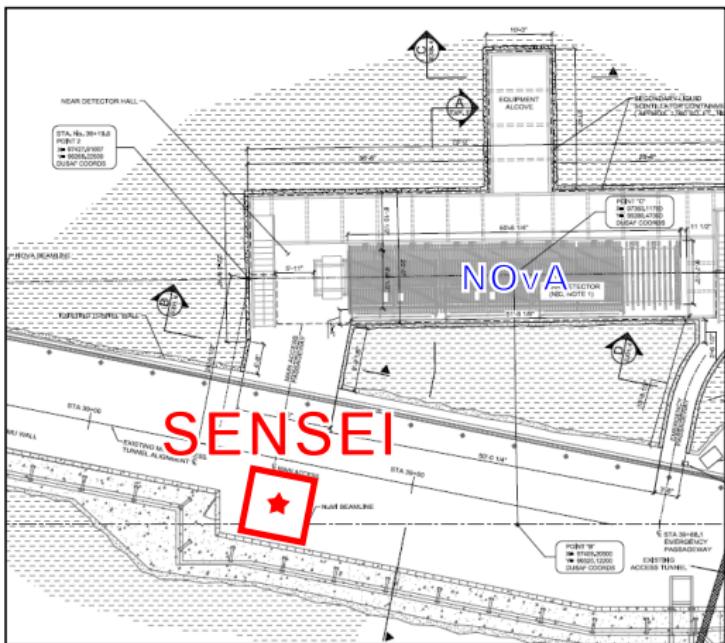
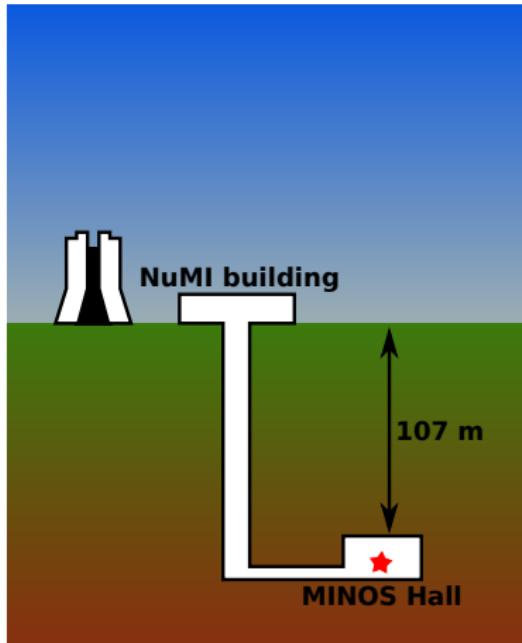


Noise vs. #samples - $1/\sqrt{N}$



Whats next: Installation @MINOS & low radiation package

Technology demonstration: installation at shallow underground site



 Fermilab

Whats next: Installation @MINOS & low radiation package

Filtered air tent installed, low radioactivity package being tested

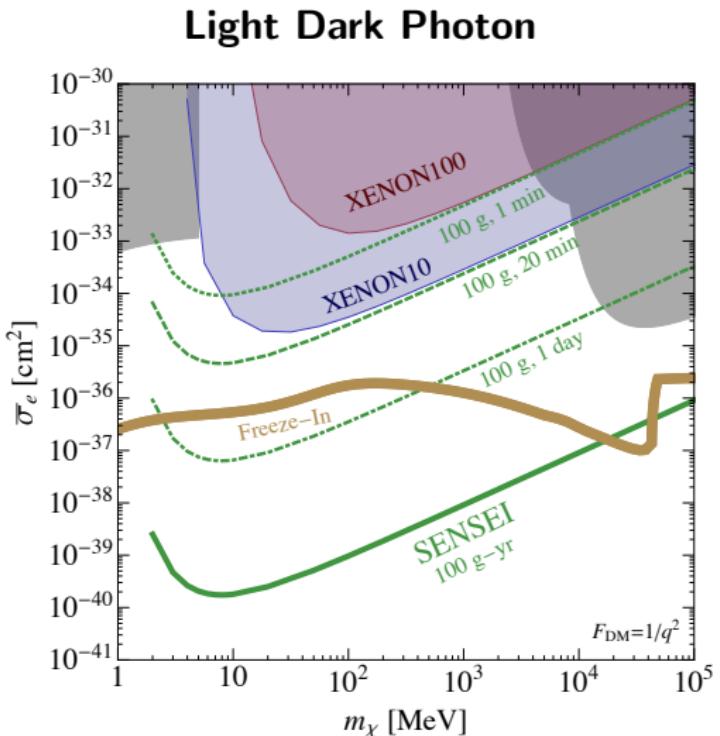


Clean-room



Low radiation
package

SENSEI: reach of a 100g, zeroish-background experiment



Rouven Essig, Tomer Volansky & Tien-Tien Yu.



SENSEI is the ultimate silicon ionization detector Unmatched performance for electron recoil channels

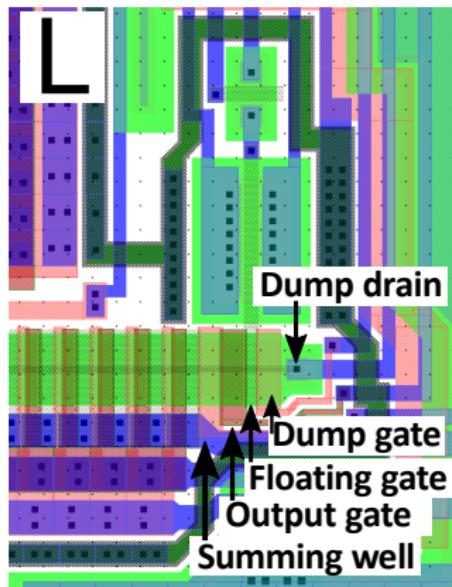
- Probe DM masses at the MeV scale through electron recoil.
- Probe axion and hidden-photon DM with masses down to 1 eV.
- Probe DM masses as low as 0.1 GeV through nuclear recoil.
- Push boundaries of coherent ν -nucleus interaction experiments.
- Improve high resolution spectroscopic instruments.

Participants

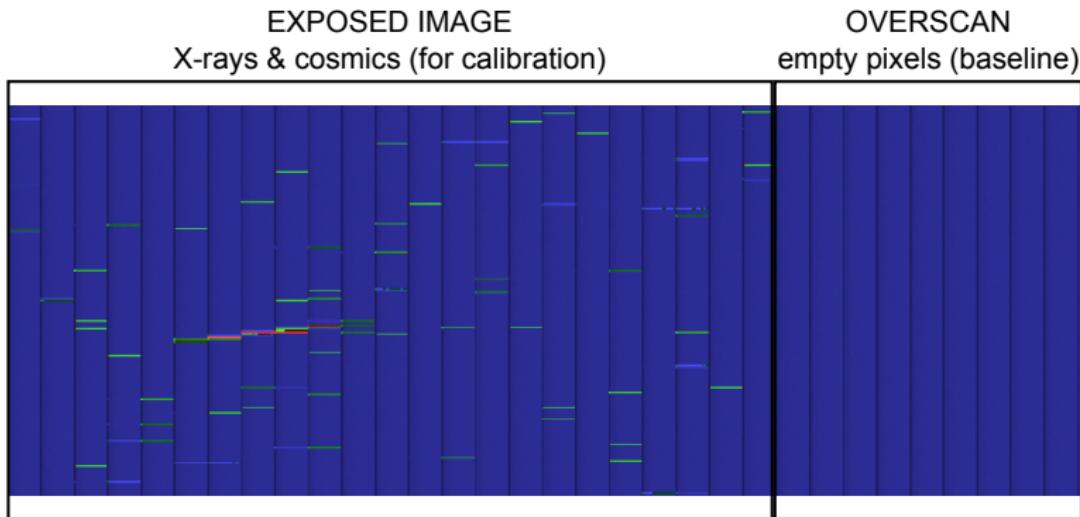
- **Fermilab:** Javier Tiffenberg, Miguel Sofo Haro
- **LBNL:** Steve Holland
- **Stony Brook:** Rouven Essig
- **Tel Aviv University:** Tomer Volansky
- **CERN:** Tien-Tien Yu

BACK UP SLIDES

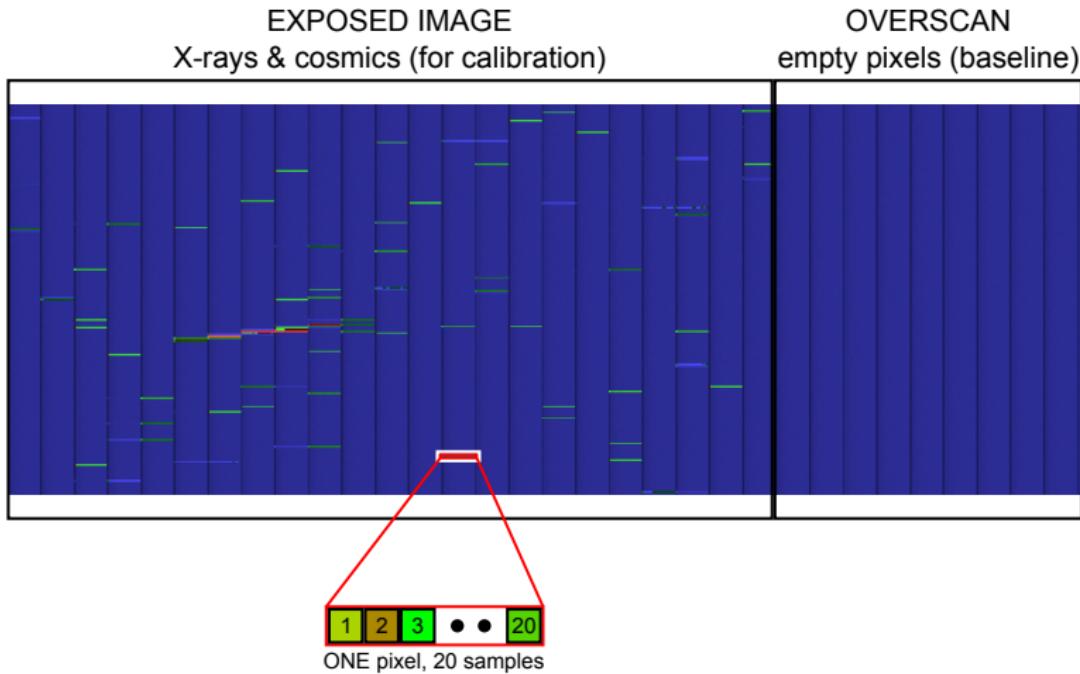
Readout stage design



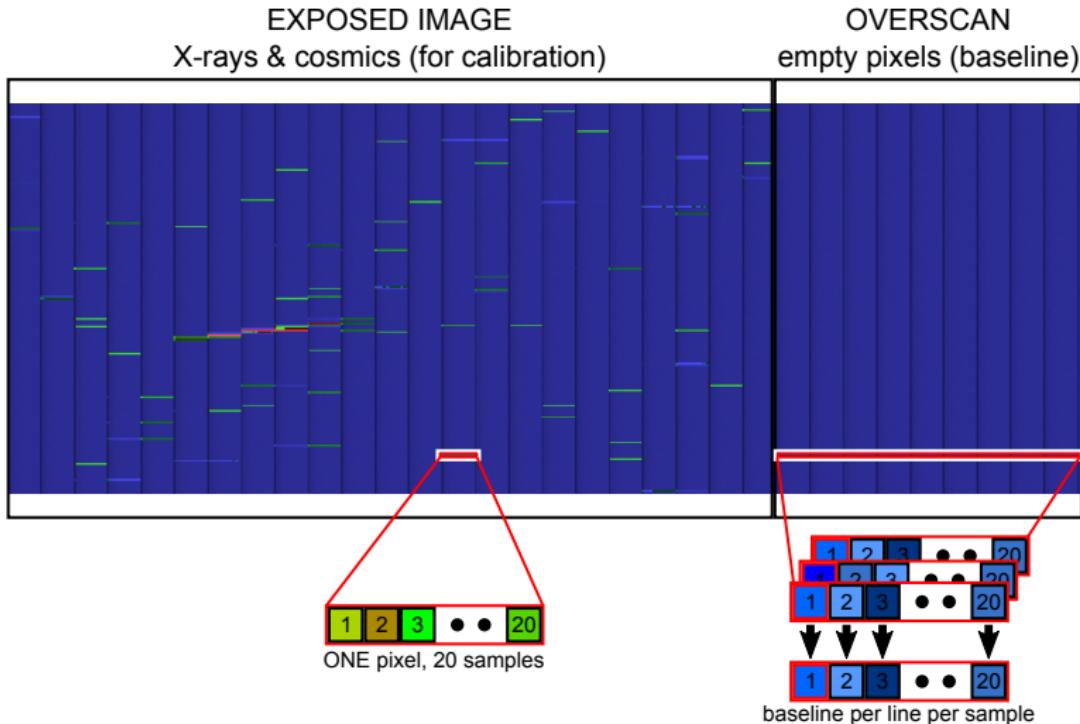
Raw image taken with SENSEI: 20 samples per pixel



Raw image taken with SENSEI: 20 samples per pixel



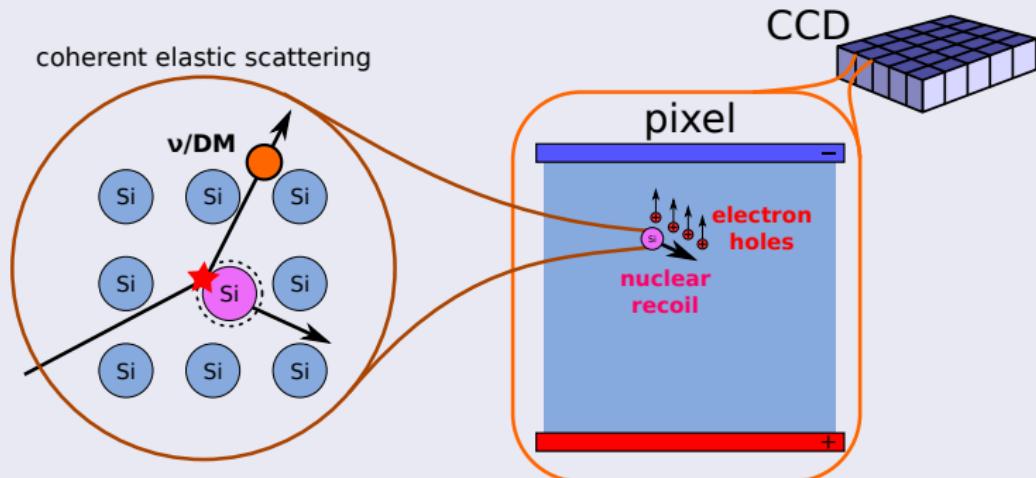
Raw image taken with SENSEI: 20 samples per pixel



Goal: lower the energy threshold in Si detectors

Detect coherent DM/ ν -nucleus interactions by measuring the ionization produced by the nuclear recoils

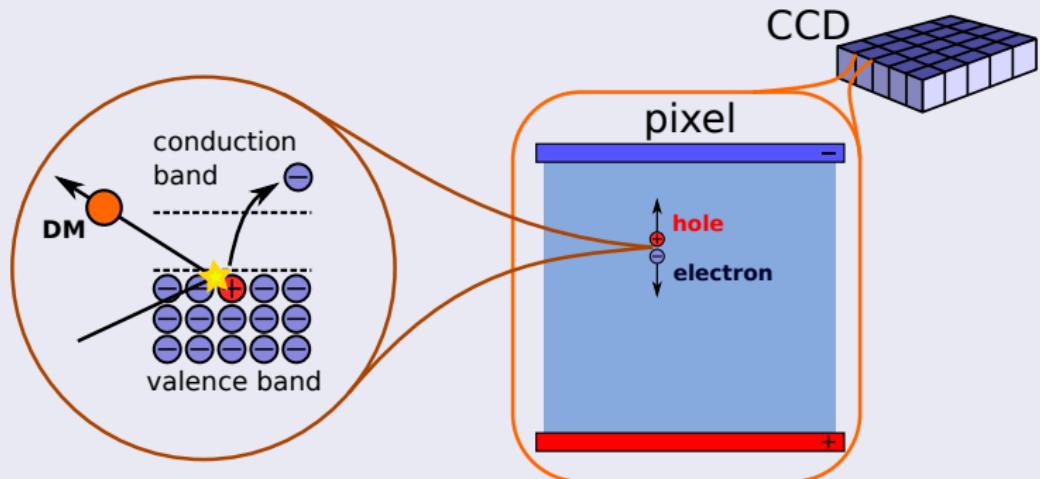
Idea: use CCDs as target and record the ionization produced



Goal: lower the energy threshold in Si detectors

Detect DM/ γ/ν -e interactions by measuring the ionization produced by the electron recoils. See arXiv:1509.01598

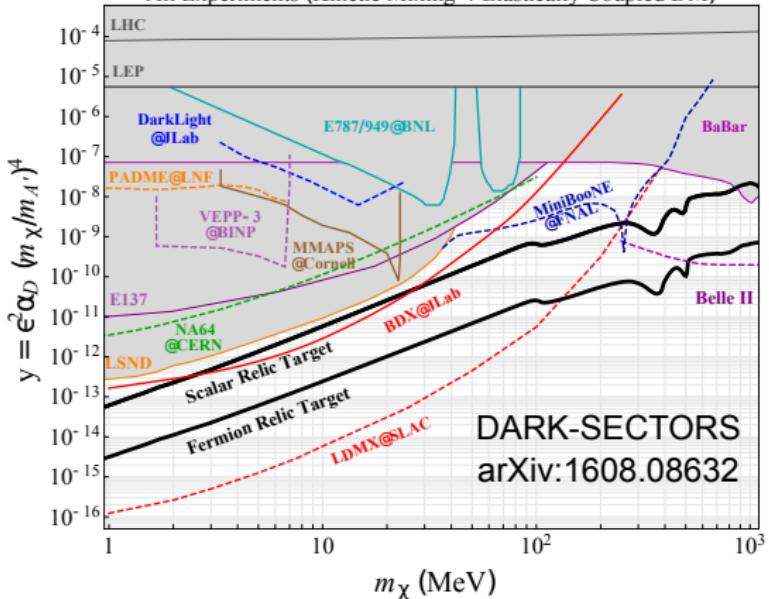
Idea: use CCDs as target and record the ionization produced



SENSEI: reach of a 100g, zeroish-background experiment

Heavy Dark Photon

All Experiments (Kinetic Mixing + Elastically Coupled DM)

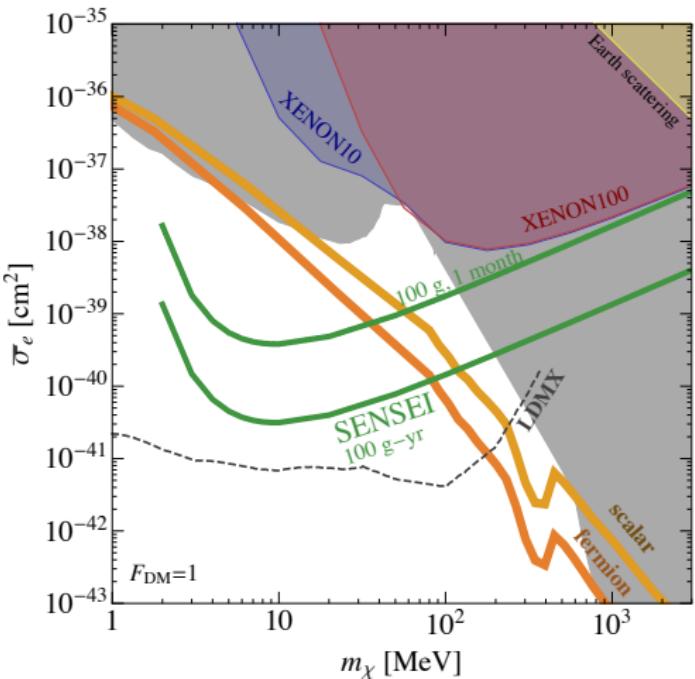


$$\bar{\sigma}_e \simeq \begin{cases} \frac{16\pi\mu_{xe}^2\alpha\alpha_D\epsilon^2}{m_{A'}^4}, & m_{A'} \gg \alpha m_e \\ \frac{16\pi\mu_{xe}^2\alpha\alpha_D\epsilon^2}{(\alpha m_e)^4}, & m_{A'} \ll \alpha m_e \end{cases}, \text{ and } F_{DM}(q) \simeq \begin{cases} 1, & m_{A'} \gg \alpha m_e \\ \frac{\alpha^2 m_e^2}{q^2}, & m_{A'} \ll \alpha m_e \end{cases}$$



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